



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Hyung-Jin JUNG et al.

Serial No.: 10/030,528

Filed: April 4, 2002

Notice of Allowance: July 7, 2004

New York, New York

Date: July 26, 2004

Group Art Unit: 1732

Examiner: S. Lechert Jr.

Confirmation No.: 5970

1732
P/2292-50

For: VACUUM INSULATOR USING GLASS WHITE WOOL AND ITS FABRICATION
METHOD

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of art cited in a communication from a foreign patent office in a counterpart foreign application, together with a form listing the same for the convenience of the Examiner.

I certify that each item of information contained in this Submission was cited in a communication from a foreign patent office in a counterpart foreign application not more than 3 months prior to the filing of this Submission.

I respectfully request that the information submitted be considered and enclose our check number 17589 in payment of the required \$180.00 fee.

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07/30/2004 BABRAHA1 00000017 10030528

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents P.O. Box 1450, Alexandria, VA 22313-1450, on July 26, 2004:

Max Moskowitz

Name of applicant/assignee or
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Signature
July 26, 2004

Date of Signature

Respectfully submitted, 01 FC:1806

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APPLICANT'S ART CITATION (Use several sheets if necessary)		Application 10/030,528		OFGS File No. P/2292-50		
		Applicant Hyung-Jin JUNG et al.				
		Filing Date April 4, 2002		Group Art Unit 1732		
U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)						
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub- class	Filing Date If Appropriate
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					
FOREIGN PATENT DOCUMENTS						
	Document Number	Date MM-YYYY	Country	Class	Sub- class	Translation Yes No
	58-106292	06-1983	Japan			X (abst.)
	2000-035193	02-2000	Japan			X (abst.)
	10-064488	03-1998	Japan			X (abst.)
	10-061875	03-1998	Japan			X (abst.)
	07-280170	10-1995	Japan			X (abst.)
	11-280987	10-1999	Japan			X (abst.)
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)						
		Japanese Office Action dated June 1, 2004 issued in related Japanese Application No. 2001-582079.				
Examiner		Date Considered				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.						